



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
United States Patent and Trademark Office  
Address: COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, Virginia 22313-1450  
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 4030

<b>SERIAL NUMBER</b> 10/673,349	<b>FILING OR 371(c) DATE</b> 09/30/2003 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 1763	<b>ATTORNEY DOCKET NO.</b> MR1035-1318
------------------------------------	---	---------------------	-------------------------------	---

## APPLICANTS

Jing-Chie Lin, Jung-Li City, TAIWAN;  
Chih-Chang Tsai, Jung-Li City, TAIWAN;  
Chien-Ming Lai, Jung-Li City, TAIWAN;  
Wen-Chu Hsiao, Jung-Li City, TAIWAN;

\*\* CONTINUING DATA \*\*\*\*\*

Jing 9-041

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

Jing 9-041

IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\* SMALL ENTITY \*\*  
\*\* 12/20/2003

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY TAIWAN	SHEETS DRAWING 10	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 1
Verified and Acknowledged	Examiner's Signature Jing 9-041	Initials			

## ADDRESS

04586

## TITLE

Method for using ammonium fluoride solution in a photoelectrochemical etching process of a silicon wafer

<b>FILING FEE RECEIVED</b> 375	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
---------------------------------------	---	--